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SEP 23 2004

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Thomas Sonderman, et al

Serial No.: 09/751,083

Filed: December 29, 2000

For: METHOD AND APPARATUS FOR
CONTROLLING WAFER THICKNESS
UNIFORMITY IN A MULTI-ZONE
VERTICAL FURNACE

Examiner: R. FULLER

Group Art Unit: 2851

Att'y Docket: 2000.044400

Fee Only

RESPONSE TO OFFICE ACTION DATED MARCH 26, 2004CERTIFICATE OF TRANSMISSION
37 C.F.R. 1.60I hereby certify that this correspondence is being transmitted by facsimile to
Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 at
1-703-872-9306 on the date below:9.23.04
DateKathy Dorer
SignatureCommissioner for Patents
P.O. Box 1450
Alexandria, Va. 22313-1450

Sir:

This paper is submitted in response to the Office Action dated March 26, 2004, for which the six-month date for response is Monday, September 27, 2004. Applicants hereby petition for a three-month extension of time to reply.

It is believed that a fee of \$950.00 is due for the extension of time; the Commissioner is hereby authorized to deduct the extension fees from Williams, Morgan & Amerson's P.C. Deposit Account No. 50-0786/2000.044400. Should additional fees under 37 C.F.R. §§ 1.16 to 1.21 be required for any reason, the Commissioner is authorized to deduct said fees from Williams, Morgan & Amerson's P.C. Deposit Account No. 50-0786/2000.044400.

Reconsideration of the application is respectfully requested.

Serial No. 09/751,083